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# Modeling and simulation of single nanobelt SnO<sub>2</sub> gas sensors with FET structure

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#### Abstract

Individual tin dioxide nanobelts were used to fabricate field-effect transistor (FET) devices. The output characteristics of these devices have been measured under various ambient conditions, and modeled with a modified drift-diffusion model in which quantum mechanical effects are taken into consideration using the density-gradient model. It is shown that the saturation of the output curves (drain current versus drain-to-source voltage) in air is not due to channel pinch-off, but rather to the saturation of the reversed-biased current of the Schottky-like contact. In this case the source and drain contacts behave like rectifying diodes and can be modeled as two Schottky diodes connected back-to-back with a series resistance from the nanobelt separating the diodes. In the presence of hydrogen the rectifying behavior of the two contacts disappears and the current through the device is limited by the resistance of the nanobelt that can be modulated efficiently by using a gate electrode.

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## 1. Introduction

Because of the enormous potential for revolutionizing chemical and environmental sensing, one-dimensional semiconducting nano-structures in various forms are attracting intense research interest. Three-terminal field-effect transistor (FET) devices are one of the most researched device structures for such applications, as evidenced by the rapidly growing number of articles published on novel nano-structure sensors with FET configurations [1–12]. Among the most commonly used nanosensing elements are tin dioxide (SnO<sub>2</sub>) nanobelts. SnO<sub>2</sub> is a wide bandgap oxide semiconductor whose electrical conductivity depends sensitively on the properties of the surrounding atmosphere. In this article the current–voltage characteristics of single-nanobelt FETs are presented and modeled by using a well calibrated drift-diffusion model.

The article is structured as follows: Section 2 presents details about the fabrication and characteristics of the nanobelt sensor.

Section 3 describes the model and details of numerical implementation. Section 4 discusses the calibration technique and numerical results, which are followed by conclusions.

## 2. Fabrication and experimental data

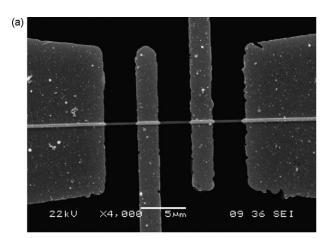
The fabrication of SnO<sub>2</sub> nanobelt devices can be briefly described as follows: SnO powder was placed on a flat rectangular piece of alumina that was inserted in the center of an alumina tube that was inserted into a horizontal tube, where the temperature, pressure, carrier-gas flow rate, and evaporation time were controlled. Alumina substrates were placed downstream from the source powder in order to collect the deposited nanobelts. Next, the gas lines were vacuumed down to less than 25 mTorr. Then, argon gas was allowed to flow through the system at a constant rate of 50 standard cubic centimeters per minute (sccm) and the pressure was set and maintained at 300 Torr. The temperature was ramped up to 1000 °C at a rate of 20 °C/min and maintained for 2 h before ramping the temperature back to 25 °C. After thermal evaporation, a wool-like deposit of single-crystalline SnO<sub>2</sub> nanobelts was retrieved from the alumina substrate and separated into individual nanobelts in an isopropyl alcohol solution via ultrasonic agitation. Some SnO2 nanobelts were dispersed

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onto a Si/SiO<sub>2</sub> substrate by placing a drop of the solution on it. A single nanobelt was identified with a mask aligner and photolithography was performed to define a photoresist electrode pattern on it. Pulsed laser deposition was used to deposit a thin film ( $\sim$ 100 nm thick) of ruthenium oxide (RuO<sub>2</sub>) onto the pattern, in order to achieve good electrical contacts to the nanobelt. RuO<sub>2</sub> has metal-like conductivity and adheres well to the SnO<sub>2</sub> nanobelts. Furthermore, in contrast to widely used contacting metals such as Cr and Ti, RuO<sub>2</sub> is an oxide and is not prone to further oxidation upon contacting the SnO<sub>2</sub>. This results in stable low-resistance ohmic contacts on the SnO<sub>2</sub> nanobelts. Next, a thin layer of gold was deposited on top of the RuO<sub>2</sub> to help ease wire attachment, and the final device was obtained after liftoff.

A scanning electron microscopy image of a SnO<sub>2</sub> single-nanobelt sensor device is shown in Fig. 1(a). There are four electrical contacts on the nanobelt in order to facilitate precise determination of the resistance and ohmicity of the contacts. For three-terminal FET measurements the center two leads are used as the source/drain contacts. A transmission electron microscopy image of a tin dioxide nanobelt is presented in Fig. 1(b). The contrast lines in Fig. 1(b) are due to strain in



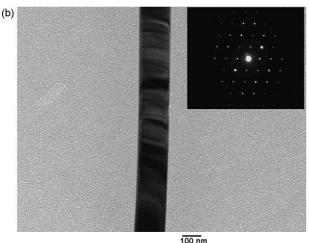


Fig. 1. (a) Scanning electron microscopy image of a tin dioxide sensor of  $5 \mu m$  channel length; (b) transmission electron microscopy image of a tin dioxide nanobelt. The inset in (b) is a TEM electron diffraction pattern showing that the nanobelt is a single crystal.

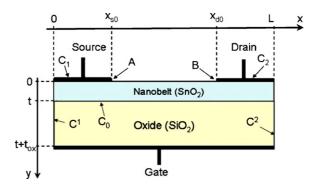


Fig. 2. Two-dimensional schematic representation of the  ${\rm SnO_2}$  single-nanobelt FET device used in simulations.

the nanobelt. The nanobelt is single-crystalline as verified by the electron diffraction pattern shown in inset of Fig. 1(b). The length of the nanobelt channel between the source/drain terminals is about 20  $\mu$ m. The width of the nanobelt is about 330 nm and its thickness about 80 nm as determined from atomic force microscopy. Heavily doped n-type silicon was used as a back gate for the device with a 250 nm thick SiO<sub>2</sub> as the gate dielectric. Fig. 2 presents a two-dimensional schematic representation of the device. As seen in this figure, the device is similar in structure to a back-gated metal-oxide-semiconductor field-effect transistor (MOSFET), in which the metal-to-semiconductor interface replaces the MOSFET's metal-to-p-n junction interface at both the source and drain terminals.

The current–voltage characteristics were measured under various ambient conditions. Fig. 3(a and b) shows the measured output characteristics (drain-to-source current versus drain-to-source voltage) of the sensor in air, at 25 and 80  $^{\circ}$ C, respectively. In these figures the gate voltage is varied from -10 to +10 V in steps of 4 V. It is important to note that the device does not obey the conventional output characteristics of MOSFET devices, where saturation occurs at:

$$V_{\rm DS,sat} = V_{\rm GS} - V_{\rm T},\tag{1}$$

where  $V_{\rm T}$  is the threshold voltage, and  $V_{\rm DS}$  and  $V_{\rm GS}$  are the drain and gate-to-source voltages, respectively. In Fig. 3(a and b), the gate voltage varies from -10 to +10 V, and, according to Eq. (1), the saturation voltage should change by 20 V. However, the saturation voltage is changed by less than a couple of volts when the gate voltage is varied from -10 to 10 V and actually appears to slightly decrease with increasing gate potential (especially at the negative gate potentials). As it will be shown in Section 4 by using numerical simulations and in Appendix A using analytical estimations, pinch-off voltage  $V_{\rm p}$  is larger than 100 V for our FET structure.

The measured output characteristics when  $H_2$  gas is introduced in the system are shown in Fig. 4(a and b) at 25 and 80  $^{\circ}$ C, respectively. Hydrogen was mixed with nitrogen to form the 2%  $H_2$  gas mixture, which was flowed through a process tube that was heated to the respective temperatures. It is apparent from these measurements that the sensor behaves like a linear resistor, whose resistance is modulated by the back gate potential. Four-point measurements indicate that the contact resistance is indeed much smaller than the bulk resistance of the nanobelt.

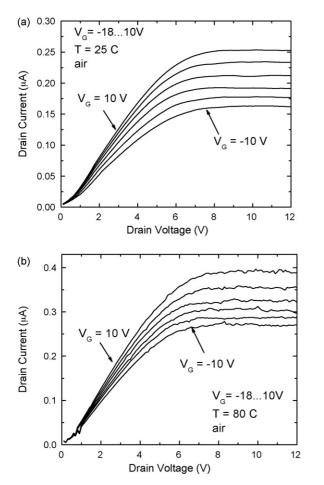


Fig. 3. Measured voltage–current characteristics of the FET device in air at (a) room temperature and (b)  $T=80\,^{\circ}\text{C}$ . Gate voltage is varied from 10 (top) to  $-10\,\text{V}$  (bottom) in  $4\,\text{V}$  steps.

#### 3. Model description

Stoichiometric tin dioxide is a metal-oxide semiconductor with a direct bandgap of 3.7 eV. The electronic transport in the tin dioxide sensor can be described by the Poisson equation coupled with the continuity and density-gradient equations [13]:

$$\nabla \cdot (\varepsilon \nabla \varphi) + q(p - n + N_{\rm D}^+ - N_{\rm A}^-) = 0, \tag{2}$$

$$\nabla \cdot (\mu_n n \nabla \phi_n) = -R_n, \tag{3}$$

$$\nabla \cdot (\mu_p p \nabla \phi_p) = R_p, \tag{4}$$

$$\frac{2\nabla \cdot (b_n \nabla \sqrt{n})}{\sqrt{n}} + \varphi - \phi_n - \Phi_n(T) = 0, \tag{5}$$

$$\frac{2\nabla\cdot(b_p\nabla\sqrt{p})}{\sqrt{p}} - \varphi + \phi_p + \Phi_p(T) = 0, \tag{6}$$

where  $\varphi$  is the electric potential, n,  $\mu_n$ ,  $\phi_n$ ,  $R_n$  and p,  $\mu_p$ ,  $\phi_p$ ,  $R_p$  are the concentrations, mobilities, quasi-Fermi potentials, and net recombination rates of the electrons and holes, respectively. In Eq. (2),  $N_{\rm D}^+$  and  $N_{\rm A}^-$  are the concentrations of the ionized donor and acceptor impurities,  $\varepsilon$  the permittivity of the semiconductor, and q is the absolute value of the electron charge. Functions  $\Phi_n(T)$  and  $\Phi_p(T)$  depend on the nature of the electron

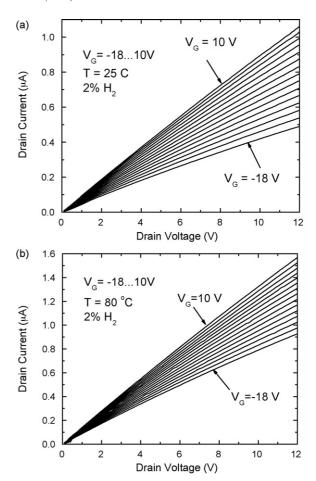


Fig. 4. Measured voltage–current characteristics of the FET device in 2% hydrogen surrounding atmosphere, at (a) room temperature and (b)  $T=80\,^{\circ}\text{C}$ . Gate voltage is varied from 10 (top) to  $-18\,\text{V}$  (bottom) in  $2\,\text{V}$  steps.

and hole statistics used. For Fermi statistics  $\Phi_n(T)$  and  $\Phi_p(T)$  are computed by numerically solving the following equations:

$$n = \frac{2N_{\rm c}}{\sqrt{\pi}} F_{1/2} \left[ \frac{q(\Phi_n - \varphi_n)}{kT} \right],\tag{7}$$

$$p = \frac{2N_{\rm v}}{\sqrt{\pi}} F_{1/2} \left[ -\frac{q(\Phi_p - \varphi_p) + E_{\rm G}}{kT} \right], \tag{8}$$

where  $N_c$  and  $N_v$  are the effective densities of states in the conduction and valence bands, respectively,  $E_G$  the bandgap, and  $F_{1/2}$  is the Fermi integral of order 1/2. Parameters  $b_n$  and  $b_p$  in the density-gradient Eqs. (5) and (6) are introduced to account for quantum confinement effects in the semiconductor device. It is assumed that [14]:

$$b_n = \frac{\hbar^2}{12qm_n^*}, \qquad b_p = \frac{\hbar^2}{12qm_p^*}, \tag{9}$$

where  $m_n^*$  and  $m_p^*$  denote the effective masses of the electrons and holes and  $\hbar = h/2\pi$ , where h is the Planck constant. Note that, if  $b_n$  and  $b_p$  are set to zero, Eqs. (5) and (6) degenerate into the classical drift-diffusion model. In our simulations, we have used  $m_n^* = 0.16m_0$  and  $m_p^* = m_0$ , where  $m_0$  is the free electron mass, in agreement with the values reported in [15] for carrier concentrations less than  $10^{18}$  cm<sup>-3</sup>.

Eqs. (2)–(9) are subject to appropriate boundary conditions that depend on the actual geometry of the sensor (see Fig. 2). In our simulations we use Dirichlet boundary conditions at the source and drain contacts ( $C_1$  and  $C_2$ ), Newmann boundary conditions at the artificial boundaries ( $C^1$  and  $C^2$ ), and mixed type boundary conditions at the semiconductor–oxide interface ( $C_0$ ). At the semiconductor–oxygen/hydrogen interface we consider a fixed-charge layer whose concentration depends on the concentration of the hydrogen in the vicinity of the SnO<sub>2</sub> surface. Eqs. (2)–(9) together with the boundary conditions are discretized and solved numerically in two-dimensions by using the finite difference approximation [16]. The density currents at the source and drain electrodes are computed as:

$$j = -q(\mu_n n \nabla \phi_n + \mu_p p \nabla \phi_p). \tag{10}$$

Although the tin dioxide sensor is an unipolar device and holes can be neglected in the bulk conductivity, the hole density current might be important when a high density of negative ions is absorbed at the surface. Such a case can occur when the surface of tin dioxide is exposed to oxygen or another oxidizing gas. For this reason the hole current may not be neglected in transport Eqs. (4), (6), and (10).

The electron and hole drift mobilities of  $SnO_2$  are assumed to be constant over the range of applied fields and of electron and hole concentrations used in the simulations. The bulk mobility of electrons is assumed to depend on the temperature according to the power law [17]:

$$\mu_n = \mu_{n0} \left( \frac{T}{300 \,\mathrm{K}} \right)^{-\gamma},\tag{11}$$

where  $\mu_{n0}$  is the bulk mobility at 300 K and  $\gamma$  is a coefficient, which in our simulation was equal to 2 [17]. The relative permittivities of SnO<sub>2</sub> and SiO<sub>2</sub> used in the numerical simulations are also considered constant and equal to 12.2 and 3.9, respectively. The concentration of the ionized donor impurities is computed by using Fermi statistics, in which for simplification we have considered only one donor level situated at 0.6 eV below the bottom of the conduction band [18]. All the other energy levels lying in the bandgap are considered either fully occupied or unoccupied and the electron concentration on these levels does not depend on the temperature. Since tin dioxide is a direct gap semiconductor, direct recombination processes are very likely to occur and the net recombination terms in Eqs. (3) and (4) can be expressed as

$$R_n = R_p = C(np - n_i^2),$$
 (12)

where C is a proportionality constant and  $n_i$  is the intrinsic concentration. The effects of the recombination terms (12) can be neglected in the modeling and simulation of I–V characteristics of tin dioxide since the conduction is given by the majority carriers, but cannot be neglected in applications where the minority carriers are important, such as in p–n junctions.

In order to accurately capture the temperature dependent characteristics of the dioxide, the temperature dependence of the bandgap should be considered carefully in the model. According to [19] we use

$$E_{\rm g} = E_{\rm g0} - \alpha T,\tag{13}$$

where  $\alpha = 6 \times 10^{-4}$  eV/K and  $E_{g0} = 3.7$  eV. The affinity of SnO<sub>2</sub> was taken to be  $\chi = 7.3$  eV [20]. Schottky barrier lowering effects induced by image charge in the metal contacts should also be used whenever the drain and source junctions are rectifying. The following empirical formula was used to describe Schottky effects:

$$\Delta \Phi = \beta \sqrt{\frac{qE}{4\pi\varepsilon}},\tag{14}$$

where  $\beta$  is an adjustable parameter. Due to the lack of available data in the literature we used the theoretical  $\beta = 1$  given by Sze [21]. E is the electric field at the interface and  $\varepsilon$  is the permittivity of SnO<sub>2</sub>.

It is important to note that the doping concentration in tin dioxide is given by the concentration of oxygen vacancies in SnO<sub>2</sub>. The doping profile of the nanobelt might slightly change as a function of the type and concentration of the gas at the surface of the nanobelt. When oxygen comes in the proximity of the nanobelt, oxygen atoms will fill in some of vacancies and so decrease the effective doping concentration in the region close to the surface of the nanobelt. When hydrogen comes in the surrounding atmosphere it will react with the existing oxygen atoms from the dioxide and increase the concentration of the oxygen vacancies in regions close to the surface of the nanobelt. This increase of the doping concentration results in a decrease of the width of the potential barrier at the contacts, and, if the concentration of the hydrogen gas is large enough, electrons will easily tunnel through the barrier, making the contacts look ohmic. The chemical reaction at the SnO<sub>2</sub> surface with H<sub>2</sub> was discussed in our previous paper [9]. However, it should be noted that there might also exist other causes that result in the modification of the nature of the contact from rectifying to ohmic. One of the most important causes is the presence of interface (surface) charges created by atoms of the gas to be detected. Surface states usually can create depletion regions in the semiconductor, as well as dipoles at the metal semiconductor interface. Both effects result in a modification of the electron affinity of the semiconductor and, as a result, of the barrier height at the drain and source contacts [22,23]. The change in the barrier height at the contacts could in principle be computed if the distribution of the surface states in the gap is known. Due to the lack of quantitative data that exist in the literature about the interface charges and the exact mechanisms that result in the change of contact conductance in the presence of external gas, we model the effects of the hydrogen by modifying the potential barrier at the source and drain contacts. Since it seems unlikely that hydrogen can affect regions of tin dioxide far away from the surface, we consider that the potential barrier is lowered only at points close to the inner corners of the metal and source electrodes (see points A and B in Fig. 2). For instance, in the case of the source electrode, the potential barrieris lowered by:

Source potential barrier lowering (x)

$$= \Delta_{\text{max}} \exp\left[-\frac{(x - x_{\text{S0}})^2}{2\sigma^2}\right], \quad \text{for } x < x_{\text{S0}}, \tag{15}$$

where  $\Delta_{\text{max}}$  is the barrier lowering at  $x = x_{\text{S0}}$ ,  $\sigma$  the standard deviation of the barrier lowering distribution along the x-direction, and  $x_{\text{S0}}$  is the x-coordinate of the inner edge of the source electrode. In the case of the drain electrode:

Drain potential barrier lowering (x)

$$= \Delta_{\text{max}} \exp\left[-\frac{(x - x_{\text{D0}})^2}{2\sigma^2}\right], \quad \text{for } x > x_{\text{D0}}, \tag{16}$$

where  $x_{D0}$  is the x-coordinate of the inner edge of the drain electrode. Parameters  $\Delta_{max}$  and  $\sigma$  should be carefully calibrated against experimental data. Our simulations show that the I-V characteristics for a large range of variation of the gate voltage do not depend significantly on the values of  $\sigma$ , as long as they are larger than a few nanometers. In the simulations presented in this article we have used  $\sigma = 5$  nm but, as mentioned before, a larger value of  $\sigma$  would not change significantly the values of the output characteristics, since the contact resistance is much smaller than the resistance of the nanobelt.

The surface states at the interface between the nanobelt and the external atmosphere can be taken into account by using a surface charge layer with density  $\rho$  (measured in C/cm²). In the presence of the charge layer the boundary condition for the electrostatic potential is:

$$\varepsilon_{\rm s} \nabla \varphi|_{\rm nanobelt} = \varepsilon_{\rm gas} \nabla \varphi|_{\rm gas} + \rho,$$
 (17)

where  $\varepsilon_s$  is the permittivity of the thin dioxide,  $\varepsilon_{gas}$  the permittivity of the external gas in the proximity of the nanobelt, and  $-\nabla\varphi|_{\rm nanobelt}$  and  $-\nabla\varphi|_{\rm gas}$  are the electric fields in the nanobelt and in the air, on each side of the surface of the nanobelt, respectively. When surface states are taken into account, the Poisson equation is solved in both the nanobelt and external gas regions, while the continuity and density-gradient equations are solved only in the nanobelt region. The density of the charge layer  $\rho$  depends on the type and concentration of the external gas. For instance, the ionized oxygen from the external atmosphere is usually absorbed during hightemperature deposition and subsequent cooling and creates a negatively charged layer at the surface of the nanobelt. This charge layer will push away the free electrons from the surface creating a depletion region, which will decrease the conductivity of the nanobelt. This effect is usually responsible for the change of the conductivity of thin films (less than a few tens of nanometers) or particulate SnO2 materials but can be neglected in films relatively thick. In our case the thickness of the nanobelt is 80 nm, the width of the depletion region is of the order of a few nanometers (see [24]), and the surface charge can be neglected. This fact is also supported by the experimental data presented in Fig. 3(b), which shows that the drain-to-source saturation voltage does not obey Eq. (1) and the saturation of the I-V curves cannot be due to a pinch-off effect.

## 4. Calibration and simulation results

The model described in the previous section has been implemented numerically and used to simulate the I-V characteristics of the tin dioxide nanobelt sensor. The transport equations consisting of the coupled Poisson, current continuity, and density-gradient equations were discretized by using the two-dimensional finite-difference approximation [21] and solved iteratively by using the Newton technique. It is important to note that by using a two-dimensional approach we tacitly neglected the fringe effects of the electric field at the two edges (in the z-direction) of the nanobelt. In our case this effect should not play a significant role since the width is more than 4 times larger than the height of the nanobelt. However, the fringe effects might play an important role if the width is not much larger than the height of the nanobelt (like in the case of circular nanowires). In this case one should either perform three-dimensional simulations or, as mentioned in [25], account for the fringe effects by using a slightly smaller permittivity for the silicon oxide.

The hole current and generation—recombination processes in the bulk of the nanobelt were neglected in the simulations since they do not affect the *I–V* characteristics significantly. The parameters that affect these characteristics the most are the bulk (effective-field) mobility at 300 K, the doping concentration profile, and the potential barrier at the metal/semiconductor contacts. These parameters were calibrated by fitting the experimental *I–V* characteristics to the simulated ones. Due to the importance of the calibration technique, we describe below an approximate method for the identification of the doping concentration, mobility, and barrier heights. The identification method presented below was used to provide an initial guess for the model parameters used in simulations. Afterwards, these parameters were slightly adjusted in order to better fit the experimental data to the self-consistent simulations.

The bulk mobility and the concentration of ionized impurities in the nanobelt can be estimated from the output characteristics of the nanobelt in the presence of hydrogen. In this case the contact resistance is much smaller than the channel resistance and the total resistance at low drain voltages can be approximated as:

$$R = \frac{L}{q\mu_n N_{\rm d}^+ W(t-d)},\tag{18}$$

where L is the channel length, W the width of the channel,  $N_{\rm d}^+$  the concentration of the ionized donor levels, and t and d are the thicknesses of the nanobelt and depletion region created by the negative gate voltage in the nanobelt, respectively. By using Eq. (23) (in Appendix A), the derivative of the channel conductance with respect to the gate voltages is:

$$\frac{d(1/R)}{dV_{\rm G}} = \frac{\mu_n W \varepsilon_{\rm ox}}{2L} \left( \frac{\varepsilon^2 t_{\rm ox}^2}{4\varepsilon_{\rm ox}^2} - \frac{\varepsilon_{\rm ox}}{q N_{\rm d}} V_{\rm G} \right)^{-1/2}.$$
 (19)

which implies that the bulk mobility can be computed using the channel conductance at  $V_G = V_D = 0$  as:

$$\mu_n = \frac{L\varepsilon t_{\text{ox}}}{\varepsilon_{\text{ox}}^2} \frac{d(1/R)}{dV_{\text{G}}} \bigg|_{V_{\text{G}} = V_{\text{D}} = 0}.$$
 (20)

By using the last equation we found that the bulk electron mobility of  $SnO_2$  is approximately  $6.9\,\mathrm{cm^2/V}\,\mathrm{s}$ , which turns out to be relatively close to the value computed by fitting the experimental data to the numerical solution of Eqs. (2)–(6) and which was found to be  $7.5\,\mathrm{cm^2/V}\,\mathrm{s}$ . The concentration of the ionized doping impurities can then be computed by solving numerically:

$$N_{\rm d}^{+} = \frac{L}{q\mu_n Wt} \frac{1}{R} \bigg|_{V_{\rm G}=V_{\rm D}=0},$$
 (21)

where t is the thickness of the nanobelt. It should be noted that this technique can also be generalized for the computation of the distribution of the concentration of the ionized doping impurities as a function of y,  $N_{\rm d}^+(y)$ , since only the impurities at the edge of the depletion region are responsible for the conductance change for a given value of the gate voltage. The concentration of ionized impurities was found to be  $N_{\rm d}^+=3.3\times10^{17}\,{\rm cm}^{-3}$  at  $T=25\,^{\circ}{\rm C}$  and  $N_{\rm d}^+=5.3\times10^{17}\,{\rm cm}^{-3}$  at  $T=80\,^{\circ}{\rm C}$ .

In Fig. 5(a and b) we present the *I–V* characteristics simulated by using the model presented in the previous section when the concentration of the hydrogen is 2%. A very good agreement is observed between these results and the experimental data presented in Fig. 4(a and b).

In ambient air, the drain and source metal contacts have a strong rectifying behavior, which can be observed in the experimental data presented in Fig. 3(a and b). It is important to note again that the saturation of the output characteristics is not due to the pinch-off effects, as Eq. (24) predicts much higher values for the drain-to-source saturation voltage than those observed experimentally. For instance, at  $V_G = 0$ , the predicted value of the drain-to-source saturation voltage is over 100 V, while experimentally the saturation was observed at approximately 6 V.

By fitting the experimental and simulated output characteristics of the nanobelt in air we have obtained that the potential barrier at the metal/semiconductor contacts is  $\Delta_{\rm max} = 0.378$  eV. The simulated output characteristics are presented in Fig. 6(a and b) for T=25 and  $80\,^{\circ}{\rm C}$ . The slight disagreement between the simulated and experimental data at low drain voltages we think is due to second-order effects that are not considered carefully in our model. For instance, at negative gate voltages the electric field at the mobility degradation at interfaces can play an important role and reduce the drain current. Fixed-changes and other impurities might accumulate at the surface of tin dioxide that is in contact with the external gas (not at the tin dioxide/metal contacts) and also create an additional electric field which can modify the electronic conduction in the channel.

In order to compare the effects of the Schottky contact resistance versus the bulk resistance of the nanobelt, Fig. 7 presents the currents through the  $20\,\mu m\ SnO_2$  nanobelt in two

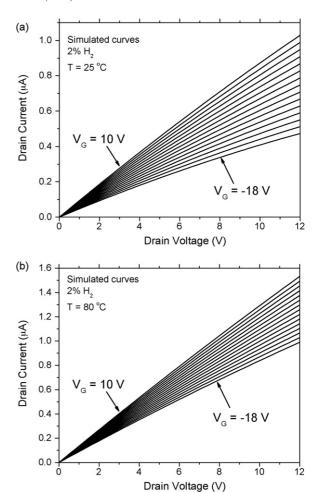


Fig. 5. Simulated voltage–current characteristics of the FET device in 2% hydrogen surrounding atmosphere, at (a) room temperature and (b)  $T=80\,^{\circ}\text{C}$ . Gate voltage is varied from 10 (top) to  $-18\,\text{V}$  (bottom) in  $2\,\text{V}$  steps.

cases: (1) only the resistance of the nanobelt is considered in the plot represented by a dashed line and the contacts were assumed ohmic and (2) the resistance of the region nanobelt between source and drain was set to zero and the contacts were treated as Schottky contacts with finite resistance in the plot represented by a continuous line. One can observe that if the drain-to-source voltage is less than approximately 3 V the bulk resistance dominates, while for drain-to-source voltages larger than 3 V the contact resistance dominates. That means that if the nanobelt sensor is biased with  $V_{\rm DS}$  < 3 V the resistance of the sensor is mostly given by the interaction of the external gas with the surface of the nanobelt and the contacts do not play a significant role. If  $V_{DS} > 3 \text{ V}$  the resistance of the sensor is mostly given by the resistance of the source and drain Schottky contacts. Since the current though the nanobelt depends exponentially on the barrier height at the metal-nanobelt contacts and the barrier height strongly depends on the type and composition of the external gas [see formulas (15) and (16)], our results suggest that one can possibly build highly sensitive sensors based on the metal-oxide semiconductor Schottky contacts.

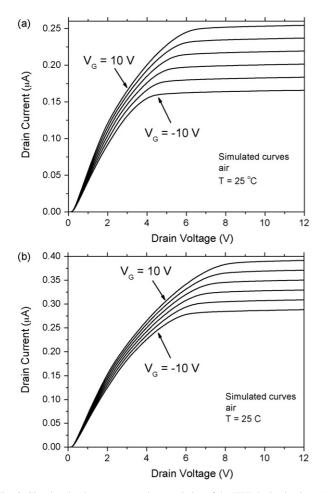


Fig. 6. Simulated voltage–current characteristics of the FET device in air at (a) room temperature and (b) T=80 °C. Gate voltage is varied from 10 (top) to  $-10\,\mathrm{V}$  (bottom) in 4 V steps.

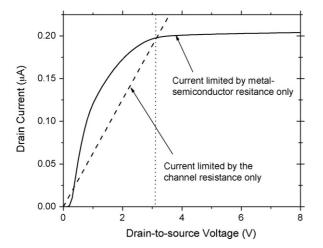


Fig. 7. Current through the nanobelt as computed by considering only the channel resistance (dash line) and the contact resistance (continuous line). Above  $V_d = 3 \text{ V}$  the contact resistance dominates and the sensitivity of the sensor is dictated by how sensitive the source and drain contacts are to changes in the composition and type of the external gas.

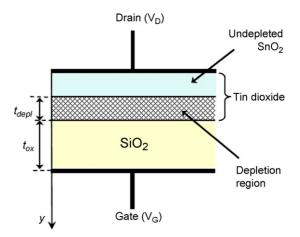


Fig. 8. Representation of the depletion region induced by negative potential on the gate with respect to the drain potential. The pinch-off voltage is given by Eq. (24)

#### 5. Conclusion

It is shown that the pinch-off effect observed when the sensor is in air is not responsible for the saturation of the output characteristics of the SnO<sub>2</sub> FET devices. Rather, the observed saturation is due to the saturation of the reverse-biased Schottky-like contact. The nature of the contact can be changed if hydrogen is introduced in the surrounding atmosphere. A physics-based model based on the Poisson and drift-diffusion equations is presented and used to simulate our FET structures. A very good agreement is observed at various temperatures between the measured output characteristics and the simulated ones.

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## Appendix A. Computation of pinch-off voltage

The pinch-off voltage of the MOSFET structure presented in Fig. 2 can be computed analytically by assuming that the length of the nanobelt is much larger than the thickness of the nanobelt and the electrostatic potential varies much slower in the direction parallel to the channel than in the direction perpendicular to the channel. Indeed, for our device, the channel length is more than two orders of magnitude larger than the thickness of the nanobelt and one can solve the one-dimensional Poisson equation in the direction perpendicular to the belt directly. When one applies a negative potential on the gate with respect to the source and drain electrodes, a depletion region will appear in the proximity of the SnO<sub>2</sub>/SiO<sub>2</sub> interface (see Fig. 8). The width of the depletion region increases when the potential difference between the drain and the gate electrodes is increased. At pinch-off, the depletion region will touch the metal electrode and will saturate the output characteristics of the sensor.

The one-dimensional Poisson equation in the *y*-direction:

$$\frac{d^2\varphi}{dy^2} = \begin{cases}
0, & \text{for } 0 < y < t - d, \\
\frac{-qN_{\rm d}^+}{\varepsilon}, & \text{for } t - d < y < t, \\
0, & \text{for } t < y < t + t_{\rm ox},
\end{cases} \tag{22}$$

where  $\varphi$  is the electrostatic potential, t and  $t_{\rm ox}$  the thicknesses of tin and silicon dioxides, respectively, q the absolute value of the electron charge,  $\varepsilon$  the permittivity of tin dioxide, d the width of the depletion region created by the gate electrode, and  $N_{\rm d}^+$  is the concentration of ionized impurities, which is assumed to be constant in the semiconductor. Eq. (22) can be integrated by assuming continuity of the electrostatic potential and of the displacement vector  $\varepsilon E$  (where E is the electric field) at y=t-d and y=t. By performing the integration in Eq. (22) one gets the following equation for the width of the depletion region:

$$d = \frac{t_{\text{ox}}}{2} \left[ -\frac{\varepsilon}{\varepsilon_{\text{ox}}} + \sqrt{\frac{\varepsilon^2}{\varepsilon_{\text{ox}}^2} + \frac{4\varepsilon_{\text{ox}}}{qN_d^+ t_{\text{ox}}^2}} (V_{\text{D}} - V_{\text{G}}) \right], \tag{23}$$

where  $\varepsilon_{ox}$  is the permittivity of the SiO<sub>2</sub>,  $V_D$  and  $V_G$  are the potentials on the drain and source electrodes, respectively. The pinch-off voltage can be computed by setting d=t, i.e. the gate potential completely depletes the semiconductor region:

$$V_{\rm P} = \frac{q N_{\rm d}^+ t}{\varepsilon_{\rm ox}} \left( t + \frac{\varepsilon t_{\rm ox}}{\varepsilon_{\rm ox}} \right). \tag{24}$$

For doping concentrations larger than  $3 \times 10^{17}$  cm<sup>-3</sup> the pinch-off voltage is above 100 V.

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